IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BAILEY III et al.

Attorney Docket No.: LAM1P124D1

Application No.: 09/943,806

Examiner: ALEJANDRO MULERO, L.

Filed: August 30, 2001

Group: 1763

Title: TEMPERATURE CONTROL SYSTEM FOR PLASMA PROCESSING APPARATUS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to Box Non-Fee Amendment, Commissioner for Patents, Washington, D.C. 20231 on November 27, 2002.

AMENDMENT C TRANSMITTAL

Box Non-Fee Amendment Commissioner for Patents Washington, D.C. 20231

Transmitted herewith is an Amendment in the above-identified application. The fee has been Sir:

alculated as sho	Claims After		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
	Amendment	MINUS	20	0	x 9 =	x 18 = \$-0-
Total Claims	14	WIINUS			42	$_{\rm X}$ 84 = \$-0-
Independent	03	MINUS	03	0	x 42 =	
-		_	Not Provious	dy Paid	\$140.00	\$280.00
Multiple Dependent Claim Present and Fee Not Previously Paid				Total	\$	\$0.00

	Applicant(s) hereby petition for a month extension(s) of time to respond to the
	aforementioned Office Action.
\sum	Applicant(s) believe that no (additional) Extension of The determined that such an extension is required, Applicant(s) hereby petition that such an extension of Time
	be granted and authorize the Commissioner to charge the required with the control of the control
	claim fee and/or extension of time fees.
	claim fee and/or extension of time fees. Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 50-0388 (Order No. <u>LAM1P124D1</u>).

Respectfully submitted, BEYER WEAVER & THOMAS, LLP

Francis T. Kalinski II Reg. No. 44,177

P.O. Box 778 Berkeley, CA 94704-0778



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Signed:

rac i meness

AMENDMENT C

Box Non-Fee Amendment Commissioner for Patents Washington, DC 20231

Sir:

This Amendment is in response to the Office Action (identified as paper no. 10) mailed October 10, 2002. Applicants representative kindly thanks the Examiner for her helpful guidance during the telephonic interview of November 26, 2002. Applicant's representative respectfully requests entry of this amendment. Please amend the above-entitled application as set forth below.

In The Claims:

Please **CANCEL**, without prejudice, claims 24, 25, and 34 as follows.

Please **AMEND** the claims as follows:

(Twice amended) 23. A method for providing temperature control to a plasma processing chamber of a plasma processing apparatus, said method comprising:

directly or indirectly measuring temperature internal to the plasma processing chamber: